| L | Hits | Search Text | DB | Time stamp |
|--------------|------|---|---|---------------------|
| Number 12 | 5 | | | 2002/01/02 |
| 12 | 5 | silicon and substrate same oxygen same nitrogen and lpd | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2003/01/09 14:37 |
| - | 0 | silicon and substrate same oxygen same nitrogen and lls | USPĀT | 2003/01/09 |
| - | 3 | silicon and substrate same oxygen same nitrogen and lls | US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2003/01/08 |
| - | 146 | silicon same substrate same oxygen same nitrogen same epitaxial | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2003/01/08 17:28 |
| - | 1 | | USPĀT | 2003/01/08 17:17 |
| - | 1 | | USPAT | 2003/01/08 17:18 |
| - | 1 | | USPAT | 2003/01/08 17:18 |
| _ | 1 | | USPAT | 2003/01/08 17:18 |
| - | 22 | silicon same substrate same oxygen same nitrogen same epitaxial same resistivity | USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB | 2003/01/08 17:29 |